

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: S. EGUCHI, et al.
Serial No.: 10/588,959
Filed: AUGUST 10, 2006
For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE
Group AU: 2891
Examiner: Julia Slutsker
Confirm. No: 4026

AMENDMENT AFTER FINAL REJECTION

Mail Stop: AF – FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 6, 2009

Sir:

In response to the Office Action mailed March 3, 2009, the period for response having been extended for one (1) month by the attached Petition for Extension of Time, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.